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| | | | | Application Number | 10/589,399 |
| | | | | Filing Date | August 14, 2006 |
| | | | | First Named Inventor | Guo-Quan LU |
| | | | | Art Unit | 1793 |
| | | | | Examiner Name | Takeuchi |
| | | | | Attorney Docket Number | 124617-00118 |
| Sheet | 1 | of | 2 | | |

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| Examiner Signature | | Date Considered | |
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| | A | Zhang, et al. "Nanoscale Silver Sintering for High-Temperature Packaging of Semiconductor Devices," TMS (The Minerals & Materials Society), 2004, 5 pp. | |
| | B | Bai, Guofeng, "Low Temperature Sintering of Nanoscale Silver Paste for Semiconductor Device Interconnection," Dissertation, Copyright 2005, 196 pp. | |
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